

# Pd-SnO<sub>2</sub> Micro-reactor Sensing Film with a Catalytic Co<sub>3</sub>O<sub>4</sub> Overlayer for Ultrasensitive Detection of Sub-ppm-level Benzene

*Seong-Yong Jeong<sup>1</sup>, Ji-Wook Yoon<sup>1</sup>, Tae-Hyung Kim<sup>1</sup>, Hyun-Mook Jeong<sup>1</sup>, Chul-Soon Lee<sup>1</sup>, Yun Chan Kang and Jong-Heun Lee<sup>1, †</sup>*

*<sup>1</sup> Department of Materials Science and Engineering, Korea University, Seoul 02841, Republic of Korea  
jongheun@korea.ac.kr*

## Abstract

Benzene, one of the most toxic and ubiquitous gases, is known to induce serious disease such as leukemia and aplastic anemia. Hence, precise detection of carcinogenic benzene is very important for monitoring of air quality and to protect human being. Unfortunately, n-type oxide semiconductor gas sensors show low responses to chemically stable BTX gases (benzene, toluene, and xylene). Moreover, similar chemical structure of BTX gases hamper their discrimination by chemiresistive variation. In this contribution, we suggest a new strategy to detect sub-ppm-level benzene vapor with high selectivity using an oxide semiconductor chemiresistors. Due to unique sensor structure consisting of a Pd-SnO<sub>2</sub> yolk-shell sensing film and a thin catalyst Co<sub>3</sub>O<sub>4</sub> overlayer, high selectivity and response (resistance ratio = 88) to 5 ppm benzene was accomplished. The sensor response toward benzene was enhanced by reforming highly stable benzene into more active and smaller species, while the cross-responses to the other indoor pollutants became low through the catalytic oxidation of the gases into less- or non-reactive species. The reforming and oxidation reaction were synergistically assisted by Co<sub>3</sub>O<sub>4</sub> catalytic overlayer and sensing layer consisting of Pd-SnO<sub>2</sub> yolk-shell micro-reactors. This method will pave a new way to the precise monitoring of critically toxic benzene in both indoor and outdoor atmospheres.

**Key words:** Benzene, Gas sensor, Pd-SnO<sub>2</sub> micro-reactor, Co<sub>3</sub>O<sub>4</sub> overlayer, gas reforming